

# MATERIALS PROCESSING WITH A HIGH POWER DIODE LASER

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## ABSTRACT

Laser materials processing is currently dominated by CO<sub>2</sub>, Nd-YAG and Excimer lasers. Continuous advances in semiconductor laser technology over the last decade have increased the average power output of the devices annually by two fold, resulting in the commercial availability of the diode lasers today with delivery output powers in excess of 60W in CW mode and 5kW in qasi-CW mode. The advantages of compactness, high reliability, high efficiency and potential low cost, due to the mass production capability of the diode laser, will inextricably shape its future in the field of materials processing. This papers reports on work exploring the feasibility of a range of materials processing applications using a Diomed 60W diode laser, transmitted through a 600µm diameter optical fibre and coupled to a 3 axis CNC workstation. The applications studied include; marking and engraving natural stones (marble and granite), marking ceramic tiles, glazing and sealing tile grouts, marking and cutting glass, marking wood, welding metal wire and transformation hardening of tool steels. The study shows that even at the present limited power level of diode laser, many materials processing applications can be accomplished with satisfactory results. Through the study an initial understanding of interaction of diode laser beam with various materials has been gained. Also, within the paper basic beam characteristics, the state of the art of high power diode laser technology and current materials processing applications are also reviewed.

## 1. INTRODUCTION

Laser materials processing is currently primarily based on CO<sub>2</sub>, Nd-YAG and Excimer lasers. These lasers co-exist within the materials processing market because each of them possesses unique and complementary features. For example, CO<sub>2</sub> lasers have the advantages of high quantum efficiency (up to 15%), high average power (up to 25kW) with good mode structure normally (for lasers less than 5kW) and good beam absorption for non-metallic materials. CO<sub>2</sub> lasers are thus often used for sheet metal cutting and the processing of non-metallic materials. Nd-YAG lasers have the advantages of being able to transmit through optical fibres and can usually provide high peak powers (up to 100kW) pulsed beam with average powers up to 3kW. Thus they are suitable for the marking and drilling of metallic components and multi-axis robotic welding. Excimer lasers produces UV beams of ns pulse and over 10 MWs of peak power with reasonably good average power (up to 1kW) which is well suitable for micro-machining and surface ablation with little heat effect on the underlying materials. Other lasers used for materials processing include CO laser, copper vapour laser and COIL laser. A common problem with these lasers is that they are all bulky and require high maintenance cost and high running cost.

The High Power Laser Diode (HPLD) however, is based on semiconductor technology. It provides the highest quantum efficiency (up to 40%), is compact (few cm<sup>2</sup> for 500W CW power), very reliable (almost maintenance free) with optical fibre delivery, has extremely low running costs, has a very long life (over 50,000 hours) and is a low voltage device (5-12V) and could therefore be run on batteries. A comparison of the HPLD with CO<sub>2</sub>, Nd:YAG and Excimer lasers is given in Table 1. Considering the unique features of the HPLD it is believed by the authors that the HPLD will establish a significant share of the materials processing market in the near future.

Table 1. A comparison of the principal features of HPLD with other lasers for materials processing.

Type of lasers	Unique features	Principal weakness	Typical applications
CO <sub>2</sub> laser	<ul style="list-style-type: none"> <li>highest average power (up to 25kW)</li> <li>high efficiency (15%)</li> <li>good beam mode</li> </ul>	<ul style="list-style-type: none"> <li>beam can not be delivered using optical fibres</li> </ul>	Sheet metal cutting, non-metallic materials marking, welding, surface treatments
Nd-YAG laser	<ul style="list-style-type: none"> <li>high peak power of pulsed beam</li> <li>beam transmittable through optical fibres</li> </ul>	<ul style="list-style-type: none"> <li>poor beam mode (for arc lamp excited system)</li> <li>surface colour sensitive</li> <li>high safety requirement</li> </ul>	Metal marking, drilling, multi-axis robotic welding, machining and paint stripping etc.
Excimer laser	<ul style="list-style-type: none"> <li>highest peak power</li> <li>very short pulse (ns)</li> <li>UV wavelength</li> </ul>	<ul style="list-style-type: none"> <li>very high cost to install and to run</li> <li>very high safety requirement</li> </ul>	Micro-machining, surface cleaning, ablation, PVD, CVD etc.
HPLD	<ul style="list-style-type: none"> <li>very compact/portable</li> <li>highest quantum efficiency (up to 50%)</li> <li>very long life (up to 100000 hrs)</li> <li>lowest running cost</li> <li>almost maintenance free</li> <li>wavelength tuneable</li> <li>low voltage device</li> </ul>	<ul style="list-style-type: none"> <li>poor beam mode</li> <li>surface colour sensitive</li> <li>high safety requirement</li> <li>wide spectrum line width</li> <li>currently high cost</li> <li>currently limited power</li> </ul>	Soldering, glazing, marking, engraving, micro-welding

Since its advent in 1962, despite its inherent advantages, the diode laser is only now increasing its number of applications. Such applications are dominated by the shorter wavelength, low power devices (630-850nm), and include CD audio system, CD-ROM, telecommunication, bar-code scanners, metrology and laser printers. Rapid and continuous enhancement of diode laser materials and fabrication technology over the last decade has increased the average power output of the devices by two fold each year, giving rise today to the commercial availability of diode lasers with output powers in excess of 200mW - high power laser diodes (HPLD), up to 100W CW power for optical fibre delivery systems and 5kW quasi-CW diode laser stacks [1]. Currently the predominant function of the HPLD is the pumping of solid-state lasers, usually Nd-YAG, because of its higher efficiency (increasing the overall conversion efficiency from 2% to 10%), increased reliability (>3000% increase in life) and improved beam quality [2]. Also, HPLD are found extensively within medicine, where they are used in the treatment of many ailments, from simple ear, nose and throat operations to cancer ablation [3].

Notwithstanding such advances, the proliferation of HPLD into more application areas, especially in materials processing, has been held in check by its prohibitively high price; currently £500 per CW watt for optical fibre beam delivery laser diode systems and £200 per CW watt for OEM diode stacks, compared to £35, £150 and £900 per CW watt for CO<sub>2</sub>, YAG and excimer lasers respectively. At present the direct application of HPLD for materials processing is limited to soldering [4-6], hardening [7] and ceramic metal powder sintering [7]. However, HPLD materials processing is an active field of research that may expand rapidly over the next decade as the 30% - 50% p.a. price reduction continues. Because semi-conductors, and hence laser diodes, can be mass produced, large economies of scale fuelled by demand can be realised by manufacturers. As a result laser diodes have the potential to become extremely inexpensive. As such, the emergence of the HPLD as one of the principal laser materials processing tool is a distinct future possibility.

## 2. LASER BEAM PROPERTIES AND RECENT DEVELOPMENTS IN HPLD TECHNOLOGY

### 2.1. Basic laser configurations and commercial HPLD systems

High power diode lasers are based on semiconductors of Group III-V compounds (such as gallium arsenide and indium phosphide). At the P-N junction of two semiconductors that have been doped with either a pentavalent or

a trivalent element, there exists a charge barrier of height  $eV_0$  due to the natural occurrence of a charge separation. The application of an external potential,  $V$ , in the direction of electron flow causes the height of the charge barrier to reduce to  $e(V_0 - V)$ , and causes the electrons to flow across the junction. Once across they are in excess and recombine with carriers of the opposite type by simply falling back into the valence band. As an electron recombines it will spontaneously emit a photon as in LED. If doping at the p-n junction is sufficient, and a high enough current is applied, it is possible to achieve a population inversion. By enclosing this junction in an optical cavity laser radiation can be sustained. The refractive index of semiconductors is quite high at their emission wavelength, so there is sufficient reflection at semiconductor/air interface to form an active cavity. The confinement of the laser beam in the lateral directions is realised by either gain guiding or index guiding. In the gain guided diode laser lasing is confined by the flux of the charge carriers at the junction, which is defined by the strip shape of electrodes. This type of laser is easier to manufacture. In the index guided laser, radiation is confined to a waveguided groove formed close to the active junction. This type of laser has superior optical properties. The majority of current HPLD are index guided.

A single diode has very limited power (<60mW). Thus commercial high power diode lasers are either based on one dimensional linear array (a bar of around 1cm long stacked with 15-150 diodes on a single sub-assembly) or two dimensional multi-laser arrays (several 1-D bars in a stack). Therefore, there is no limit on the maximum power diode laser stacks can deliver. Currently a few  $\text{cm}^2$  diode stack can deliver up to 500W CW optical power and 5kW Q-CW optical power [1].

HPLD are usually driven with a current source (currently up to 130A) with low voltage (< 20V for CW diodes and <100V for Qausi-CW laser diodes ). Thus diode lasers have less electrical risks associated with them than other high power lasers, and can sometimes be run on batteries. The typical size of the HPLD driver is comparable to a PC computer deck. The life of the diode laser is over 50,000 hours, many times longer than other high power lasers.

Commercial HPLD systems are either in a stack form for OEM applications or fibre optical delivered systems for non-OEM users. Companies that manufacture or supply high power diode laser stacks (up to 5kW Q-CW, duty factor of 1-20%, beam divergence of 10 to 40 degrees FWHM) or optical fibre delivered systems (up to 100W CW, 0.2 to 0.4 NA, 200 to 2000 $\mu\text{m}$  core fibre) include SDL, Opto Power Corp., AT&T Bell in USA, Sony Corp. in Japan, GEC, Diomed Ltd., Spectra Physics, Laser Lines (supplier), AMS Electronics (suplier), and Pacer Components Ltd. (supplier) in UK. CeramOptec GmbH and Jenoptik Laser Diode GmbH in Germany and Tutcore in Finland.

## 2.2. Optical charateristics of HPLD relavent to materials processing

HPLD have many special optical properties that are different from other types of high power lasers. These properties include wide spectrum band, high beam divergence, non-symmectric beam distribution and astigmatism.

**Wavelength:** It is know that optical energy absorption by materials and beam focuaability are dependent on the laser beam wavelength. The wavelength at which diode lases emit at is dependent upon the bandgap energy, cavity length and index of refraction of the semiconductor, thus is material dependent. The most common compounds and their emitting wavelengths are given in table 2:

Table 2. Diode laser wavelength for different materials.

Semiconductor Compound	Wavelength (nm)
GaAlAs	720-880
InGaAs	940-990
AlGaInP	630-690

Diode laser wavelength is also strongly influenced by temperature, up to 0.4 nm/ $^{\circ}\text{C}$  [8] which affects all of the three factors mentioned above. Therefore commercial diode lasers have very precise temperature control. This feature can also be used for the wavelength tuning of the diode laser. The diode laser wavelength is further affected by the driving current, typically 0.025nm/mA [8]. Therefore varying the power of the diode laser may well cause the variation of laser wavelength. When individual laser diodes are stacked to form a high power stack further increase spectrum bandwidth of the combined beam is expected. Typical sprectum bandwidth of a high power diode laser stack is 2-20nm.

Beam divergence and asymmetry: Most currently available diode lasers are edge emitting devices, with a Fabry-Perot lasing cavity, with its length determined by the length of the chip and transverse dimensions defined by an index guided process or a gain guided process. These very small and asymmetric dimensions result in 20 to 40 ° half angle divergence in the direction perpendicular to the facet of the laser and 2.5 to 6 times smaller divergence in the parallel axis [8]. Thus the beam is asymmetric and diverges into an elliptical cone. Therefore the laser beams from a single diode chip or diode array are not directly usable for materials processing. Usually a specially designed collimating lens system (e.g. a high numerical aperture spherical lens group) and a cylindrical lens telescope or an anamorphic prism pair have to be used for the beam shaping in order to achieve a low divergence (1-2° half angle) symmetric beam. Since beam divergence parameters vary significantly from laser to laser, the collimating and beam shaping optics have to be designed specifically for each case. When an optical fibre is used to collect the laser beam, asymmetry will not affect the beam output since the beam is homogenised through the fibre.

Astigmatism : Unlike most of the other materials processing lasers, the diode laser beam is astigmatic. This is caused by the longitudinal separation (around 5µm for index guided diode lasers) between the diode laser's emission points parallel and perpendicular to the junction. This is due to the directional dependence of the refractive index of the lasing cavity. Astigmatism will affect the beam divergence and beam focus for materials processing. Usually a weak cylindrical lens is inserted in the beam path at an angle to correct this. The use of optical fibre beam delivery may reduce this effect by homogenisation.

Polarization: Diode lasers are linearly polarized with an electrical vector parallel to the diode laser junction. It is known that polarisation will affect laser cutting in different directions. Therefore direct use of diode laser beam for omni-materials processing (without using optical fibre beam delivery) would require a depolariser (phase retarder) to change it to a circular polarised beam.

From the above analysis, it can be seen that there is a great advantage in using an optical fibre delivered diode laser beam for materials processing. However, since the output laser beam is the combination of those coming from a number of laser diode emitters, a highly incoherent multimode output beam will result. The minimum beam spot size that can be focused after the optical fibre delivery is usually limited to the core size of the optical fibre, which is usually greater than 0.5mm for lasers of over 50W power.

### 2.3. Recent HPLD developments

It is impossible to include all the literature on the subject in this paper. Some main areas of development are given below.

Beam shaping techniques: Clarkson et al [9] at the University of Southampton, UK have developed a multiple reflection beam shaping technique that will focus laser diode bar output to a low divergence, circular spot of 200mm in diameter. Liao et al [10], at the Massachusetts Institute of Technology are developing accurate anamorphic microlenses that will efficiently collimate the inherent astigmatic output of tapered unstable resonator diode lasers, thus allowing the beam to focus down to a circular spot close to that of the fundamental mode. Bayer et al [11] at Fraunhofer Institute für Laser Technik, Germany studied the possibility of producing the laser beam profile delivered from a bundle of optical fibres by controlling the power input to each optical fibre.

Vertical-Cavity Surface Emitting Laser Diode (VCSEL) arrays and phase locking: VCSEL arrays emit a circular symmetric output beam of around 1mm from a facet perpendicular to the active junction. As such the emitting area is larger and thus higher brightness is obtained. VCSEL arrays can be mass produced at low cost as monolithic 2-D wafers. Phase locking of 2-D VCSEL arrays has been achieved by employing grid contacts [12], patterned mirrors [13] phase shifter array [7] and in external Talbot cavity structures [14].

## 4. PREVIOUS WORK ON USING HPLD FOR MATERIALS PROCESSING

There have been a very limited R&D activities on using HPLD for materials processing with the first reported work in 1991. The cited materials are briefly described in the following.

Soldering: Initial studies by Polijanczuk et al [4] at Hull University, UK, and later work by Krause et al [15] at the Fraunhofer-Institut für Lasertechnik, Germany, and by a team at McDonnell Douglas Aerospace, USA [16] into soldering using fibre and optically coupled HPLD has established the feasibility of the process. This has been further developed into a commercial system for surface mount soldering by Sony in Japan, Hull University

and Diomed Ltd, UK and McDonnell Douglas Aerospace, USA, delivering 10-50W output power through 1mm fibre bundles [3, 5, 16, 17]. Research by Tonshoff et al [6] at the Laser Zentrum Hannover eV., Germany has investigated the use of HPLD for soft soldering of copper foils and the contacts of electronic components on PCB's. Soldering is up to now the only successful commercial material processing application using HPLD.

Sintering metal-ceramic powders: The sintering of metal or ceramic powders to manufacture precision machine parts using lasers is expected to be an extremely important segment of desktop manufacturing and rapid prototyping. Such an application would be highly suitable for a low cost HPLD system. Preliminary work by Chen et al [7] at the University of Connecticut, with a fibre coupled HPLD system emitting a maximum output power of 25W with a beam spot diameter of 0.5 to 1mm, showed that with an accurately controlled dwell time even alumina powders could be successfully sintered. As yet no actual results of these experiments have been published.

Hardening stainless steel: Work by Chen et al [7] showed that 400 series stainless steel tape with a thickness of 0.1mm and width of 6mm could be hardened by using a 15W diode laser with 1mm spot diameter and exposure time of 3 seconds, followed by auxiliary cooling. An increase of hardness in the high temperature region of the sample was achieved.

Cutting and drilling: The cutting and drilling of various materials has been investigated by Tonshoff et al [6] at Laser Zentrum Hannover e.V. Germany, and by McDonnell Douglas Aerospace, USA [16]. The materials studied included stainless steel (1mm thickness), steel (0.5mm thickness), aluminium (0.25mm thickness), copper (0.25mm thickness), plastics, epoxy, paper and wood with maximum laser power of 45W and spot size of 0.5mm and typical cutting speed of 4mm/s. A detailed report on the effect of cut (such as HAZ, dross, kerf width etc.) were not given. It has been recognised that due to the large focused beam size of the HPLD the efficiency of laser cutting is not particularly good compared to other types of lasers.

Welding stainless steel and carbon steel sheets: McDonnell Douglas Aerospace has demonstrated the welding of stainless steel and carbon steel sheets using a 50W HPLD at 2mm/min welding speed [16]. The efficiency of welding is shown to be very low and the heat affected zone is very high compared to other lasers.

Marking on metals: McDonnell Douglas Aerospace has investigated the feasibility of marking on stainless steel, anodised aluminium and aluminium using a 50W HPLD [16]. The effect of marking was not reported.

## 5. NEW DEVELOPMENTS AT UMIST FOR HPLD MATERIALS PROCESSING

### 5.1. Equipment description

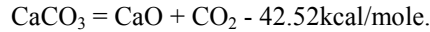
Research work at UMIST on materials processing using high power diode lasers started in April 1995 with both industrial and government funding. A Diomed 60W CW diode laser system was installed at UMIST with supporting beam focusing optics (1:1 and 1:2), processing nozzle and an Unimatic Engineering 3-axis CNC workstation coupled to a CAD/CAM (Virtual Gibbs) system. The laser beam was delivered to the processing head (lens and nozzle assembly) through an armoured optical fibre with 1000µm core diameter. The laser is based on GaAlAs semiconductor laser arrays radiating 810nm  $\pm$ 20nm infrared beams. A visible diode laser of 650nm was used coaxial to the main diode laser beam as an aiming beam. The power supply to the diode laser system is directly from a 240V AC mains. No water cooling of the laser system is required for the system. Research was carried out to study areas of materials processing that have not been reported in the public literature and those suitable to the present power levels of the diode laser. The aim of the study was to explore the industrial applications of the HPLD and to understand the basic characteristics of the involved processes.

### 5.2. Marking and engraving natural stones

Experiments were conducted for marking and engraving marbles and granite using the Diomed HPLD. These materials are often seen in buildings and monumental cemeteries. Inscription on these materials is extremely difficult and time consuming based on the current mechanical chiselling carried out by stone masons. This research work aimed to study the feasibility and effects of using the diode laser for flexible engraving and marking on these materials. The compactness, reliability and ease of use of diode lasers would greatly benefit the process compared to using other types of lasers.

5.1.1. Engraving marble : Marble is a metamorphic rock composed of recrystallized calcite or dolomite with impurities of quartz chalcedony, hematite and pyrite, as well as some organic compounds [18]. The main

component of marble (95% by mass) is  $\text{CaCO}_3$  lime stone, which breaks down at temperatures between  $825^\circ\text{C}$  and  $950^\circ\text{C}$  in accordance with the recognised chemical reaction [19]:



Such temperatures can easily be achieved with power densities as low as  $10^3$ - $10^5 \text{ W/cm}^2$ . As one can see, the breakdown results in carbon dioxide gas ( $\text{CO}_2$ ) and unslaked lime ( $\text{CaO}$ ) which adheres loosely to the unprocessed substrate beneath and can be easily removed with assisted gas.

Marbles of different colours (uniform black, uniform blue, uniform off-white and multi-coloured) were irradiated with the Diomed 60W diode laser with powers ranging from 35W to 50W, spot diameter of 2mm and processing speed of 1 -10mm/s. At the same time a coaxial Argon gas jet of 6-20l/min was applied to the melt pool to remove the loose  $\text{CaO}$  which was sucked away with a closed-up extraction nozzle. The experiments showed that for darker uniformly coloured marbles, engraving depths of 0.1mm to 0.75mm per pass with engraving width of 1 to 2mm can be achieved with little heat affected zone. No cracks were seen on the untreated part and edges were clean as shown in Figure 1. A relationship between the engraved depth and processing speed under various laser power densities is given in Figure 2. Multiple passes were used to produce deeper engraved lines. The advantages of technique over the existing mechanical means and other pulse laser marking techniques are that wider and deeper lines can be engraved with high efficiency and precision, and the whole process can be computer controlled. Since there is no need to vaporise or even melt the material, the energy efficiency is relatively high.

Un-engraved part      Engraved groove

Figure 1. a) An example of HPLD engraved grey marble tile (operating parameters: 50W, 2mm beam diameter, 10mm/s traverse speed in two passes). b) Microscopic picture showing the edge quality of the engraved groove, x 50.

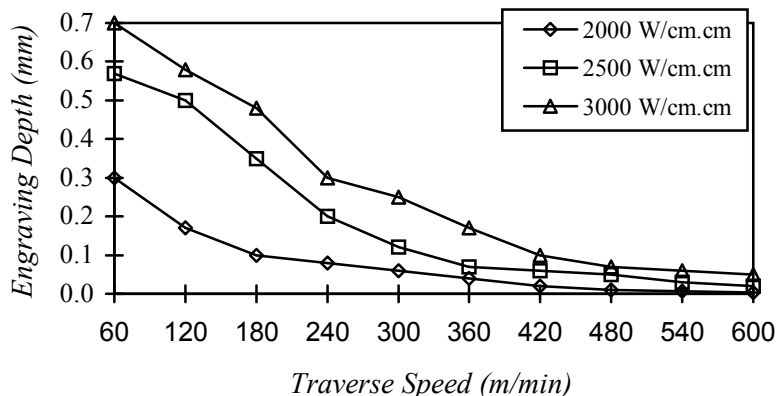


Figure 2. Relationships between diode laser processing speed and marble engraving depth.

For multi-coloured marbles with and pale coloured marbles, it was more difficult to produce uniform engraving lines directly using HPLD. The light coloured marbles displayed almost 100% reflection to HPLD beam, whilst the characteristic white vein that occurs in many marbles also reflect most of the DPLD beam. To overcome the

problem, a black water based ink was applied to marble surface with thickness of less than 0.01mm prior to laser processing. This had improved process efficiency significantly, with uniformly single pass engraved depth to around 0.5mm on light beige, multi-coloured and white marbles with laser power of 50W.

Figure 2. Examples of diode laser engraved marble tiles. (a) surface (b), cross section

Marking granite: Granite is a crystalline igneous rock that consists mainly of quartz ( $\text{SiO}_2$ ), alkali feldspar and plagioclase, typically 80-100% by volume, and other accessory minerals such as biotite, magnetite and zircon, around 20-0% by volume [20]. As such, the laser induced chemical reactions that occur are very different to those experienced by marble. Various types of granite tiles were irradiated using the Diomed 60W diode laser operating in CW mode with powers of 30-60W and spot size of 2mm. The traverse speed were varied from 1 to 10mm/s. After laser processing a dark green porous vitrified glazed mark was seen on the laser processing tracks as shown in Figure 3. Since one of the major constituents of the granite is quartz, which is almost 100% silica, the resultant glazing effect is believed to be largely vitrified silica after the granite is melted by the laser beam. This has produced a permanent mark on the granite tiles. The glazed lines are found uniform although the glaze is slightly porous which could be removed by mechanical means afterwards if necessary. The multi-colour granite processing exhibited similar problems as for marble and the application of an absorbent ink was used successfully to enable uniform marking. An experimental relationship between the marking (glazing) depth and laser processing parameters is shown in Figure 4.

(a) (b)

Figure 3. Examples of laser marked multicoloured granite. 50W, 8 mm/s a) distant view b) microscopic view x 50

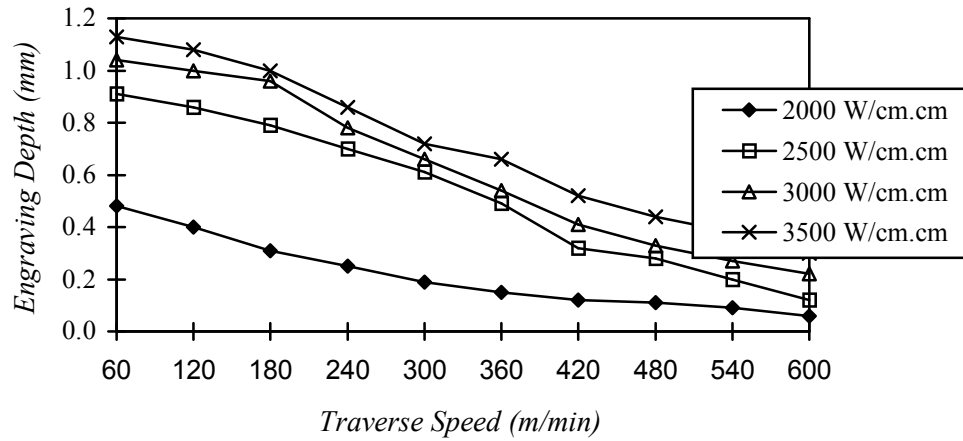


Figure 4. Experimental relationships between diode laser processing parameters and marking depth on granite.

## 5.2. Marking ceramic tiles and chinaware

Chinaware are seen in everyday life such as tea cups, ceramic plates and vases etc. Ceramic tiles are also used in domestic and industrial environment for floor and walls tiling. Currently the decorations on these ceramic items are largely carried out either by painting before glazing or by mechanical engraving or by chemical etching during the manufacturing stages of the tiles. The aim of this study was to investigate the feasibility and characteristics of flexible marking on finished ceramic products by using a diode laser.

**Tiles:** Ceramic tiles of various types (vitrified and clay quarry tiles) were marked using the Diomed diode laser. These tiles consist of 53% (for vitrified tiles) to 72% (for clay quarry tiles) ball clay (70%  $\text{SiO}_2$ , 19%  $\text{Al}_2\text{O}_3$ , 1.6%  $\text{TiO}_2$ , 2%  $\text{K}_2\text{O}$ , 0.8%  $\text{Fe}_2\text{O}_3$ , 0.5%  $\text{NaO}$ , 0.4%  $\text{MgO}$ , and 0.2%  $\text{CaO}$ ), and other materials such as limestone (5-10%), silica (10-24%) and reprocessed tile (13%). Laser markings on these tiles were produced by producing codification phases of the tile materials which result in glazed tracks of different colours from those of the tiles. This was achieved by laser melting of tiles at operating parameters of 20-30W, 1-2mm spot diameter and traversing speed of 2 - 10mm/s. The experiments showed that while tiles reflected almost all of the laser beam leaving no marks at all unless an absorbent ink was applied prior to laser marking, while beige (such as the back of the white vitrified tiles) or darker coloured (such as brown clay quarry tiles) tiles can be marked easily using the Diomed diode laser. The colour of the glaze is dependent on the tile material used. Uniform lines of 0.5 to 2mm with good edge quality were produced on both types of tiles with the line width on the clay quarry tiles half of that on the back of vitrified tiles for the same operating conditions (Figure 5 c.d). It is expected that by applying different oxide materials on the surface before laser processing, marked patterns of different colours can be developed after laser glazing.

(a)

(b)



(c)

(d)

Figure 5. Laser marking on ceramic tiles. a) distant view of diode laser generated marks on the back of a vitrified ceramic tile. b) distant view of the diode laser generated marks on a clay quarry tile. c) microscopic view of marked line on the vitrified ceramic tile, x 25, d) microscopic view of marked line on the clay quarry tile, x 25.

Engraving on chinaware: A domestic ceramic plate was marked using the HPDL of 40W by the melt and blow process (gas flowrate of 20l/min). The engraved lines, where the glaze was removed exposing the porous substrate, were then coloured by spraying pigmented solution (ink) which soaked into the porous engraved part whilst the paint on the untreated part was wiped out using a cloth. An example of the marked china plate with multi-colour pigmentation afterwards is shown in figure 6.

Figure 6. A domestic ceramic plate decorated by the HPLD.

### 5.3. Glazing enamels for sealing tile grouts

Ceramic tiles are applied to walls and floors in hospitals, public lavatory, restaurants and biological/nuclear laboratories. The predominant problems with commercial available tiles grouts in between the tiles is that over time they become contaminated with dirt, germs and other harmful agents due to the porous nature of the material. If the tile grouts can be sealed with a layer of glazed facing so that it becomes impervious to contaminating agents, the appearance, hygiene and the life of the tile grouts can be improved. In nuclear processing plants, the use of totally sealed tiling could reduce the radioactive contamination to the building. Also the tiling with sealed grouts could also be used for contamination tie-down during nuclear decommissioning. The aim of this study was to investigate the feasibility of sealing the tile grouts using a high power diode laser. The study showed that the existing tile grouts are not suitable for sealing or glazing using laser beams. This is because large quantity of organic substances exist in the tile grouts as binding agents which upon heating will disintegrate and cause charring of the grouts. Therefore a new grout formula was developed to suit the laser glazing or sealing. It has been found through numerous experiments that a chamotte based compound can be used as the heat resistant base grout while a low softening point enamel was used in the top layer. After irradiation by the diode laser beam of 30W power at traversing speed of 3mm/s, a layer of glassy surface was formed on the top layer of the grouts and sealed (welded to) with the tiles. The formed surface has no cracks or

porosity. No pre-heating was required unlike most of previously reported laser glazing techniques. Details of this work are presented in a separate paper [21].

#### 5.4. Cutting and marking glass

To date a fair amount of research has been conducted to investigate cutting glass with lasers such as the work of Kurobe et al [22], Schaeffer et al [23] and Chen et al [24]. The work reported here was to replicate these studies using a HPLD and to access any advantages or disadvantages of HPLD. 2mm thick soda-lime-silica glass was cut with the Diomed 60W diode laser operating at 50W to 60W and a beam spot diameter of 2mm and traversing speed of 5-10mm/s. When the glass was not coated with an absorbent ink, 10 passes were needed to complete the cut. When a black water based ink was applied (less than 0.01mm thick) to the glass prior to laser cutting, only 4 passes were required operating at 50W, 10mm/s and a beam spot size of 2mm.

It was observed during the experiments that the HPLD cutting process, for both coated and un-coated glass samples, was the result of the development and propagation of thermally induced stress cracks. The cracks can be best initiated at the outer edge of the samples, perpendicular to the surface, where the beam was first incident upon the glass. They then propagated across the glass, consistently following the laser path locus and increasing in length with each pass. The directionality of the cuts was quite reasonable, deviating only approximately 0.5mm from the laser path locus for a cut length of 40mm for un-coated glass samples. Such a deviation was also recorded by previous workers using YAG and CO<sub>2</sub> lasers [22, 25]. The cut surface profiles of the HPLD cut samples as shown in Figure 6(a) were found very smooth and clean not displaying the typical rough, undulated appearance characteristic of the cut surface profiles produced by mechanical methods.

To mark on the glass, a black water based ink was applied prior to laser marking. Higher traversing speed (20mm/s) was used compared to marking. One or two passes were found sufficient to generate microcracks near the surface. There is no need to initiate cracks from the edge of the glass. Laser marking can be initiated from anywhere on the glass. No deviation of the mark from the laser path was recorded, even when complex geometry such as circles were marked (shown in Figure 6b). Difficulty of cutting small curvatures were reported for CO<sub>2</sub> and YAG lasers due to deviation from the laser tracking locus [22].

(a) (b)

Figure 6. a) Cross section of a glass cut by the HPLD, x \*\*\* b) Surface appearance of a glass marked by the HPLD, x \*\*\*.

#### 5.5. Marking/engraving wood

The utilisation of lasers, in particular CO<sub>2</sub> lasers, for marking on wood is an established area of research which has identified a number of unique advantages [26] and Swaczyna et al [27]. The results reported here were an attempt to examine the ease with which wood marking may be carried out using a HPLD. A limited domestic wood board with a common pine pale wood on the surface was marked and engraved with the HPLD. Engraving parameters used for this wood were 40W power at 1 to 2mm beam spot and 2 to 30mm/s traversing speeds. Depths of 0.5 to 4mm grooves with clear edge quality were produced at the above parameters as shown in Figure 7b. For marking the wood using the diode laser much high speed (35-40mm/s) can be used for the laser power of 40W and beam spot of 2mm. It has been found from the experiment that the marking line width is dependent on the direction of marking with uniform lines produced along the grains of the wood and non-uniform lines across the grains shown in figure 7. c.

(a) (b) (c)

Figure 7. HPLD engraved and marked wood. a) Engraved wood top view (operating parameters: 10mm/s, 40W and 1.5 mm beam spot size) , b) engraved wood cross section view x 50. c) Marked wood showing direction dependence.

#### 5.6. Paint/lacquer removal

Current method of laser paint removal is based on pulsed or Q-switched YAG and CO<sub>2</sub> lasers aimed at removing paint without damaging the substrate. This has been largely applied to aircraft and helicopters to facilitate necessary periodic metallurgical inspection. The research work reported in the following describes the feasibility and characteristics of removing paint and lacquer from both metallic and non-metallic substrates. In this experiment a mild steel aerosol substrate (0.22mm thickness) with multi-coloured paint of around 40µm and a ceramic tile painted with 0.5mm thick of lacquer were irradiated by the diode laser at various powers, beam spot sizes, traverse speeds and argon gas flowrate of 3-15 l/min through the processing nozzle. The experiments showed that for effective, uniform multi-colour paint removal from metallic substrates (shown in Figure 8. b), laser power density has to be above a threshold of 1.5kW/cm<sup>2</sup> and traversing speed below 20mm/s at the threshold power density, i.e. a minimum of 0.75 J/ mm<sup>3</sup> is required. If the energy delivery rate is below this level non-uniform paint removal may result in which laser beam was reflected by the red and white coloured paints (figure 8.a, the middle line). Although no surface damage was visible to the substrate where the paint had been removed, bending of the sample in the direction of laser had occurred around the irradiated path. This is partly due to the fact that the substrate material used was very thin thus heat dissipation rate is low. Removing paint/lacquer from ceramic tiles was found to require much less energy than that for metal substrate. For example operating a 20W, beam spot size of 3 mm and traversing speed of 25mm/s, the 0.5mm thick lacquer was removed 100% to substrate.

(a)

(b)

Figure 8. An example of HPLD removal of multi-coloured paint from metal substrate. a) Distant view, b) closed up view.

#### 5.7. Welding metal wires

A paper clip was welded (figure 9) by the HPLD at powers of 55W and beam spot size of 1mm and interaction time of 3 seconds. This shows the feasibility of applying the HPLD for a range of welding applications including wire mesh welding, jewellery repair etc.

Figure 9. A paper clip welded by the HPLD, x 50

#### 4. DISCUSSION

4.1. Interaction of HPLD with metallic materials: From our experiments we found that although theoretically shorter wavelength of HPLD should have better beam absorption than YAG and CO<sub>2</sub> lasers for metals, since the diode laser is currently limited to very low power, little effect can be generated on large metallic sheets due to high thermal dissipation rate. So far we have been only successful of welding and treating thin wires and thin sheets (such as hardening of saw blades and razor blades) of low overall mass volume using HPLD.

4.2. Interaction of HPLD with ceramics, organic and non-metallic materials: Beam absorption by these materials have been found to vary with surface colouring with red and white colour reflecting most of the laser beam. However when an absorbent ink is applied, almost all types of surfaces can be treated with significant thermal effects for the treated part and little heat affected zone next to the laser interaction zone. This type of materials is found to suit the current power levels of the high power diode laser very well.

4.3. Comparison with CO<sub>2</sub> laser and YAG lasers: The unique features of diode laser is its portability and reliability. The weaknesses of diode laser in price and power are only temporary. Beam mode could be improved as for YAG lasers. It is expected that in the near future HPLD may find its market in portable devices, flexible desk top devices.

#### 5. CONCLUSIONS

Basic characteristics and state of art of high power diode laser technology together with existing R&D work in materials processing using HPLD have been reviewed. New applications of the HPLD for materials processing have been investigated by the authors are described. The investigations showed clearly the potential of using high power diode laser as a flexible desk-top system for:

- marking/engraving marble and granite - a potential market in monumental services
- marking ceramic tiles and glass - a potential market in domestic chinaware decoration
- sealing tile grouts - a potential market in hygienic treatment in restaurants and public lavatories
- marking wood - furniture and
- cutting glass - building and computer storage
- welding wire and wire mesh - manufacturing industry and jewellery
- selective paint removal - portable graffiti removal, laser vacuum cleaner
- hardening - manufacturing industry for tool tips, saw blades, knife edges etc.

Many are unique to the diode laser; portability, low running costs, etc.. Through these studies, an understanding of the characteristics of interactions between diode laser beam with various materials was gained. Desk top systems, fibre optic delivery enables multi-axis processing system easily,

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Patent: BNFL:

4 patents:

<b>Organisations</b>	McDonnell Douglas Aerospace (USA)	Sony (Japan)	University of Connecticut (USA)	Laser Zentrum Hannover eV (Germany)	University of Hull (UK)
<b>Activities in materials processing</b>	Cutting, Drilling, soldering, marking and welding	surface mount soldering	powder sintering hardening	soft soldering cutting	micro-soldering

Table 1. A summary of principal features of various currently used high power lasers in materials processing industry with a comparison with high power diode lasers.

Type of lasers	Advantages	Disadvantages	Typical applications
CO <sub>2</sub> laser	<ul style="list-style-type: none"> <li>• highest average power (up to 25kW)</li> <li>• high efficiency (15%)</li> <li>• good absorption by non-metallc materials</li> <li>• good beam mode for lasers up to 5kW</li> <li>• relatively lower cost to install and to run</li> <li>• less safety requirement</li> </ul>	<ul style="list-style-type: none"> <li>• beam can not be delivered using optical fibres</li> <li>• poor absorption by metals</li> <li>• non-portable</li> <li>• requires regular services</li> </ul>	sheet metal cutting, non-metallc materials marking, welding, surface treatments (hardening, alloying, cladding, texturing, paint stripping and surface glazing etc.), slotting, rapid prototyping etc.
Nd-YAG laser	<ul style="list-style-type: none"> <li>• high average power (up to 3kW)</li> <li>• high peak power of pulsed beam</li> <li>• beam transmittable through optical fibres</li> <li>• good beam absorption for metals</li> </ul>	<ul style="list-style-type: none"> <li>• poor beam mode</li> <li>• poor absorption by non-metallc materials</li> <li>• surface colour sensitive</li> <li>• high cost to install and to run</li> <li>• non-portable</li> <li>• high safety requirement</li> </ul>	Metal marking, drilling, multi-axis robotic welding, machining and paint stripping etc.
Excimer laser	<ul style="list-style-type: none"> <li>• highest peak power</li> <li>• very short pulse (ns)</li> <li>• good beam absorption for both metallc and non-metallc materials</li> <li>• “cold” machining possible</li> </ul>	<ul style="list-style-type: none"> <li>• very high cost to install and to run</li> <li>• very high safety requirement</li> <li>• not transmittable through optical fibres</li> </ul>	Micro-machining, surface cleaning, ablation, PVD, CVD etc.
Diode laser	<ul style="list-style-type: none"> <li>• portable</li> <li>• highest quantum efficiency (up to 40%)</li> <li>• very long life (up to 100000 hrs)</li> <li>• lowest running cost</li> <li>• almost maintenance free</li> <li>• beam transmittable through optical fibres</li> <li>• good beam absorption by metals</li> <li>• potentially low cost to install</li> </ul>	<ul style="list-style-type: none"> <li>• currently high cost to install</li> <li>• currently low average power</li> <li>• Poor coherent</li> <li>• poor beam mode</li> <li>• poor absorption by non-metallc materials</li> <li>• surface colour sensitive</li> <li>• high safety requirement</li> </ul>	soldering , glazing, marking , micro-soldering